APPLICATION DATA SHEET

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Title of Invention:	ETCHING METHOD, SEMICONDUCTOR AND FABRICATING METHOD FOR THE SAME

Legal Representative:

Attorney or Agent:	Donald R Studebaker
Registration Number:	32815
Attorney or Agent:	Jeffrey L Costellia
Registration Number:	35483

Customer Number Correspondence Address: 22204

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Assignee (Publish): MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD.
1006, Oaza Kadoma
Kadoma-shi 571-8501 Osaka JP

INVENTOR(s):

Primary Citizenship:	Japanese
Given Name:	Kenshi
Family Name:	KANEGAE
Residence City:	Osaka
Residence Country:	JP
Address:	1-1-10-B103, Himuro-cho,

Takatsuki-shi Osaka, 569-1141 JP

Primary Citizenship:	Japanese
Given Name:	Shinichi
Family Name:	IMAI
Residence City:	Osaka
Residence Country:	JP
Address:	22-12, Ogura-higashimachi Hirakata-shi Osaka, 573-1174 JP

Primary Citizenship:	Japanese
Given Name:	Hideo
Family Name:	NAKAGAWA
Residence City:	Shiga
Residence Country:	JP
Address:	131, Oda-cho, Omihachiman-shi Shiga, 523-0064 JP